

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of
Akihoki ISHIBASHI et al.

Serial No. 09/692,211

Filed: October 20, 2000

For: METHOD OF FABRICATING
NITRIDE SEMICONDUCTOR
DEVICE



Attention: Applications Branch

CERTIFICATE OF MAILING

I hereby certify that this correspondence is being deposited with
The United States Postal Service with sufficient postage as First
Class Mail in an envelope addressed to: Assistant Commissioner
for Patents, Washington, D.C. 20131, on 3/6/01

CORRECTION TO TRANSMITTAL OF CERTIFIED PRIORITY DOCUMENT

Honorable Assistant Commissioner for Patents
Washington, D.C. 20231

Sir:

On February 14, 2001, Applicants respectfully submitted a certified copy of the
priority document to perfect the claim for priority. However, Applicants have identified a
typographical error. In particular, Japanese Patent Application No. 11-299640 was
incorrectly listed as being filed on October 10, 1999. The correct filing date should be listed
as October 21, 1999.

A certified copy of the priority document was previously submitted, and therefore,
Applicants have not attached an additional copy of priority document.

Respectfully submitted,

Eric J. Robinson

Reg. No. 38,285

NIXON PEABODY LLP

8180 Greensboro Drive, Suite 800

McLean, Virginia 22102

(703) 790-9110